

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)
)
	John Chen et al.)
)
Serial No.:	10/693,773) Art Unit
) 2886
Filed:	October 24, 2003)
)
For:	SYSTEM AND METHOD FOR MEASURING)
	CONCENTRICITY OF LASER TO CAP)
)
Confirmation No.:	1968)
)
Customer No.:	022913)
)
Examiner:	Isiaka O. Akanbi)

AMENDMENT "C" AND RESPONSE TO FINAL OFFICE ACTION WITH RCE

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the FINAL Office action mailed July 12, 2007 (the "Office Action"), please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper; and

Remarks/Arguments begin on page 7 of this paper.